



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

F0286

USA Patent Application  
Jun Akedo  
Serial No.: 09/752,360  
Filed: December 29, 2000

ULTRA FINE PARTICLE FILM  
FORMING METHOD AND APPARATUS

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CERTIFICATE OF MAILING  
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Hon. Commissioner of Patents and Trademarks  
Washington, D.C. 20231  
S I R :

INFORMATION DISCLOSURE STATEMENT

Respectfully submitted herewith are copies of two Japanese Patent Applications, namely JP-A-10-208998 (publication no. 2963993) and JP-A-11-117328 disclosed and discussed on pages 9 and 15 of the specification.

A PTO-1449 form is presented to list the two submitted references. Translations of these Japan language documents are not available to attorney for applicant.

This submission meets the requirements of 37 CFR §1.56, 1.97 and 1.98(a) and MPEP 609.

Respectfully submitted,  
Jun Akedo

by: \_\_\_\_\_

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CERTIFICATE OF MAILING UNDER 37 CFR SECTION 1.8(a)

I hereby certify that the accompanying Information Disclosure Statement, PTO-1449 form and 2 references are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents & Trademarks, Washington, D.C. 20231, on April 10, 2001.  
Dated: April 10, 2001

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